



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Daniel Alvarez, Jr. and Jeffrey J. Spiegelman  
Application No.: 10/692,018 Group: 1724  
Filed: October 23, 2003 Examiner: Frank M. Lawrence, Jr.  
Confirmation No.: 8519  
For: METHOD FOR PURIFICATION OF LENS GASES USED IN PHOTOLITHOGRAPHY

CERTIFICATE OF MAILING OR TRANSMISSION	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or is being facsimile transmitted to the United States Patent and Trademark Office on:	
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COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A Notice of Allowance and Issue Fee Due was mailed for the above-captioned case on April 24, 2006. These comments are being submitted with the payment of the issue fee.

U.S. Patent 6,555,492, issued to Farber, *et al.*, discloses an adsorber catalyst system containing at least 30%, and preferably 50-60%, zeolite. *See* Col. 5, lines 5-8. In the Statement of Reasons for Allowance, the Examiner states that at a minimum zeolite level of 30% by weight there could be up to 50% alumina, 10% lanthanum oxide, and 8.5% nickel by weight. While Farber states that the adsorber catalyst system contains at least 30% zeolite, it appears that the composition stated in the Statement of Reasons for Allowance is a hypothetical composition constructed by the Examiner.

Authorization is hereby granted to charge any additional fees which may be due in this matter to Deposit Account No. 08-0380.

Respectfully submitted,

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Dated: July 21, 2006